

*Notice of References Cited*

09/555,987

Applicant(s)/Patent Under  
Reexamination  
VANDEN HEUVEL ET AL.

Examiner

San-ming Hui

Art Unit

1617

Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,518,751-	05-1996	de Boer et al.	--
	B	US- -			
	C	US- -			
	D	US- -			
	E	US- -			
	F	US- -			
	G	US- -			
	H	US- -			
	I	US- -			
	J	US- -			
	K	US- -			
	L	US- -			
	M	US- -			

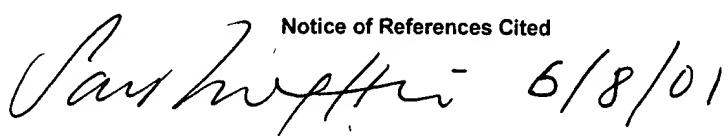
## FOREIGN PATENT DOCUMENTS

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	N	- -				
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## NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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 San-ming Hui - 6/8/01